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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Confirmation No: 9025

Hideki MUNAKATA

Attorney Docket No: 107242-00021

Serial Number: 09/926,173

Group Art Unit: 1762

Filed: September 18, 2001

Examiner: Wesley D. Markham

For: WAFER STORAGE CASE, PROCESS FOR PREVENTING DUST
GENERATION THEREOF AND WAFER STORING METHOD

RESPONSE TO FINAL REJECTION UNDER 37 C.F.R. § 1.116

BOX AF

Commissioner for Patents

P.O. BOX 1450

Alexandria, VA 22313-1450

Date: October 8, 2004

Sir:

This paper is in reply to the Office Action dated July 20, 2004.